



PATENT APPLICATION

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2812

Application No.: 10/801,821

Examiner: S. Mulpuri

Filed: June 22, 2004

Docket No.: 111587.01

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING
METHOD THEREOF

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the February 9, 2005 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.